Electronic Acknowledgement Receipt					
EFS ID:	3903589				
Application Number:	10518371				
International Application Number:					
Confirmation Number:	6811				
Title of Invention:	Plasma chemical vapor deposition method and plasma chemical vapor deposition device				
First Named Inventor/Applicant Name:	Hiroshi Mashima				
Customer Number:	22850				
Filer:	Marvin Jay Spivak/Dalibor Tudman				
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File Listing:

Document Doc Number	ument Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
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1		263787US2PCTIDS1.pdf	844836	yes	12				
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	Multipart Description/PDF files in .zip description								
	Document Description		Start	Start End					
	Information Disclosure Statement Letter		1	1					
	Information Disclosure Statement (IDS) Filed (SB/08)		2	2					
	Foreign Reference		3	12					
Warnings:			1						
Information:									
2	2 Fee Worksheet (PTO-06)	fee-info.pdf	30026	no	2				
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Warnings:		•							
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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.